

Transaction Information

Tool ID	LKTK761
Tool Status	Running Wafers
Location	Woodlands, Singapore
Wafer Size	300 mm
Fab Section	Lithography
Tool Available Date	2024-02-01

General Product Information

Vendor Supplier	TOKYO ELECTRON LIMITED
Model	LITHIUS
Vintage	2006
Serial No	G260826
Asset Description	TEL LITHIUS KRF DUV Track
Software Version	3.00.71
CIM	SECS
Process	KRF

Hardware Configuration (Fab)

System Type	Description	Quantity	Status
Main System	DEV	5	OK
Main System	Main Tool	1	OK
Main System	TCU	1	OK
Main System	TCT	2	OK
Main System	COT	3	OK
Main System	BWEE	1	OK
Handler System	IRAM	1	OK
Handler System	PRA	2	OK
Handler System	IRAS	1	OK
Handler System	CRA	1	OK
Factory Interface	FOUP	4	OK
Options System			
Others			

Hardware Configuration (Subfab / Auxilliary Units)

Description	Quantity	Status
T&H Controller	1	OK
DEV Chemical Cabinet	1	OK
AC Power Box	1	OK
COT Chemical Cabinet	1	OK



Missing/Faulty Parts / Accesories List

Description	Quantity
NONE	

Tool Pictures

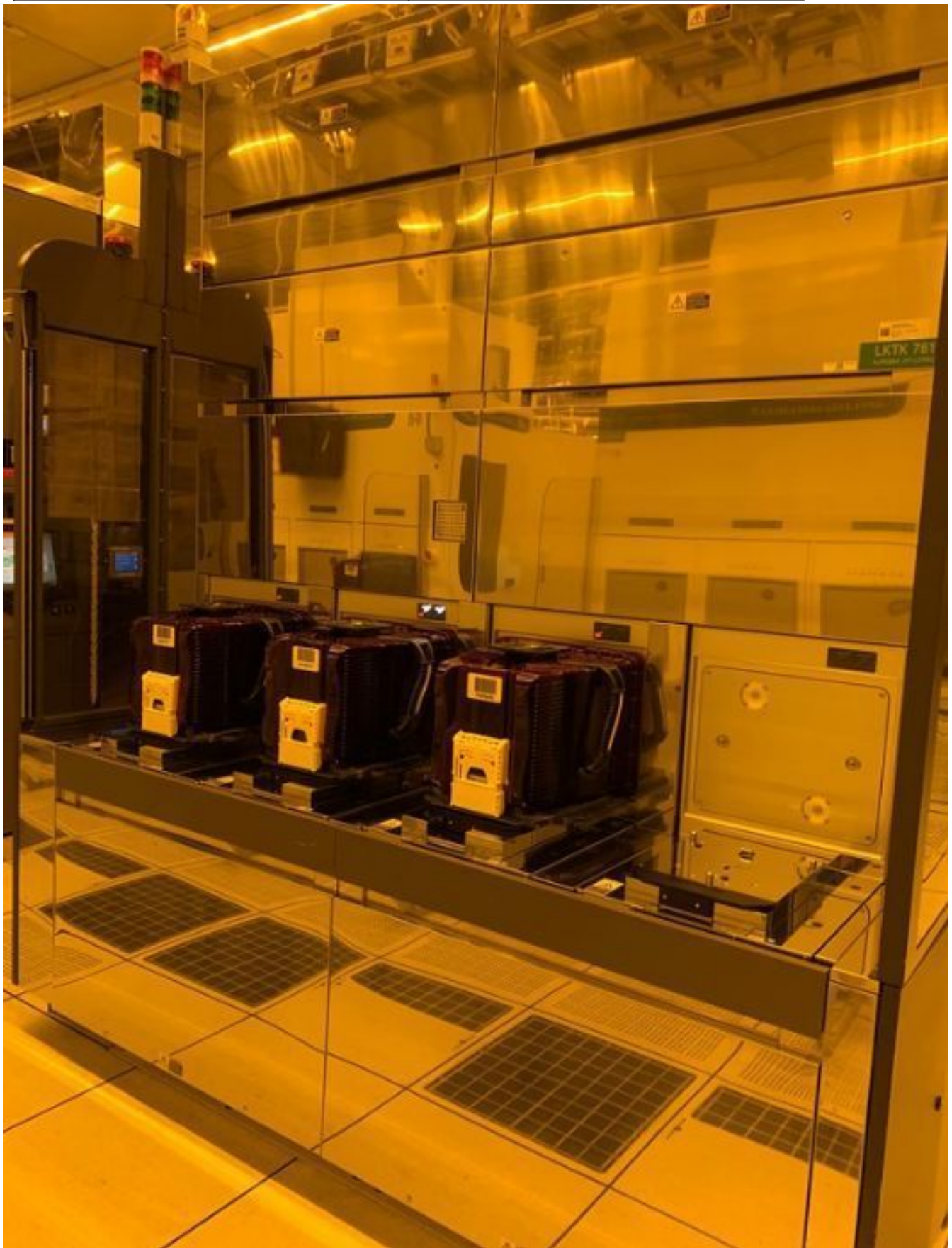
General	LKTK761 Machine Configuration
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5-0 IRAS	4-9 BWEE	3-23	3-36	2-49 CPHP	2-58  CIH#4	2-23	1-0 CRA	1-4 FOUN	
	4-8	3-18 CPHP	3-35	2-44 CPHP	2-57  CIH#1	2-18 CPHP			1-3 FOUN
	4-7 SBU	3-17 CPHP	3-34	2-43 CPHP	2-56 ADH	2-17 CPHP			
	4-6 SBU	3-16 CPHP	3-33 LHP	2-42 CPHP	2-55 ADH	2-16 CPHP			1-2 FOUN
	4-0 IRAM	3-15 CPHP	3-32 LHP	2-41 CPHP	2-54 ADH	2-15 CPHP			
		3-14 CPHP	3-0 PRA	2-40 CPHP	2-0 PRA	2-14 CPHP			
		3-13		2-39		2-13			
		3-12 CPHP		2-38 HCP		2-12 HCP			
	3-11	2-37		2-11					
	3-10 CPHP	2-36 HCP	2-10 HCP						
	3-9	2-35 TRS	2-9 TRS						
	3-8 HCP	2-34 WCPL	2-8 WCPL						
	3-7	2-33	2-7 TRS						
	3-6 HCP	2-32 HCP	2-6 HCP						
	4-5 THS	3-5 DEV	2-5 TCT	1-1 FOUN					
4-4	3-4 DEV	2-4 TCT							
4-3 TRS	3-3 DEV	2-3 COT							
4-2 IHCP	3-2 DEV	2-2 COT							
4-1 IHCP	3-1 DEV	2-1 COT							

※本図はCONFIGの情報のみ示しています。

※ This figure shows only module configuration.















Additional Configuration Files

Additional Configuration Files

	Machine ID	G260826
	Software	3.00.71
	Tool Model	TEL LITHIUS
	Block	2 Blocks
CSB	Loadport	4
PRB1	TCT	2
	COT	3
	HCP	6
	WCPL	2
	ADH	3
	CPHP	11
PRB2	DEV	5
	HCP	2
	CPHP	7
	LHP	4
IFB	BWEE	1
	IHCP	2
Others	Pump Type	Entegris RGEN-02 4cc Entegris RGEN-02 10cc
	Dev Nozzle Type	NLD Nozzle
Accessories	AC Power Box	1
	T&H Controller	Asahi
	Chemical Cabinet	2